

Notice of References Cited	Application/Control No. 10/749,688	Applicant(s)/Patent Under Reexamination KAEWELL, JOHN DAVID	
	Examiner Nathan W. Ha	Art Unit 2814	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-2004/0104462 A1	06-2004	Tao et al.	257/686
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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